

**Notice of References Cited**

Application/Control No.

10/517,483

Applicant(s)/Patent Under  
Reexamination  
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Examiner

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Art Unit

2872

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0041323	04-2002	Hayashi et al.	347/224
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	J	US-			
	K	US-			
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**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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